

IN THE CLAIMS:

Kindly replace claim 5 as follows:

92 5. (Amended) The MEMS device of claim 1, wherein the moveable element moves in a direction perpendicular to the plane of the substrate.

Kindly add new claims 6-8 as follows:

93 --6. (New) The MEMS device of claim 2, wherein the moveable element moves in a direction perpendicular to the plane of the substrate.

7. (New) The MEMS device of claim 3, wherein the moveable element moves in a direction perpendicular to the plane of the substrate.

8. (New) The MEMS device of claim 4, wherein the moveable element moves in a direction perpendicular to the plane of the substrate.--